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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 09/808,705
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Inventor Shubneesh Batra et al.
Assignee Micron Technology, Inc.
Priority Group Art Unit 2823
Priority Examiner H.M. Lee
Attorney's Docket No. MI22-2397
Title: Methods of Forming Polished Material and Methods of Forming Isolation
Regions

PRELIMINARY AMENDMENT

To: Mail Stop Patent Application
Commissioner for Patents
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Sir:

This is a preliminary amendment accompanying a Request for Continuation Application for the above-entitled patent application. Prior to examining the application, please enter the following amendments.

AMENDMENTS

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.